| Search Notes | Application/Control No. | Applicant(s)/Patent under Reexamination |
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| | 10/789,171 | PAI ET AL. |
| | Examiner | Art Unit | |
| | Nathan W. Ha | 2814 | |

| SEARCHED | | | |
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| Class | Subclass | Date | Examiner |
| 257 | 734 - 740 | 9/1/05 | *h* |
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